IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

M Re U.S. Patent Application		I hereby certify that this paper is being deposited with
Applicant:	Shigeru Okamoto) the United States Postal Service as FIRST-CLASS mail) in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Arlington, Virginia 22313-1450, on this date.) May 10, 2004 Date F-CLASS.WCM Attorney for Applicant
Serial No.:	09/521,389	
Conf. No.:	9947	
Filed:	March 8, 2000) Appr. February 20, 1998 Attorney for Applicant)
For:	EMBEDDED ELECTRO- CONDUCTIVE LAYER AND METHOD FOR FORMATION THEREOF))))
Art Unit:	2823))
Examiner:	Maldonado, Julio J.)

<u>AMENDMENT F</u>

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 13, 2004, please amend the above-identified Application as follows: